

Rev. 9/00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Michael A. Vyvoda et al.  
For : WAFER SURFACE THAT FACILITATES  
PARTICLE REMOVAL  
Serial No. : 09/776,009  
Filing Date : February 2, 2001

Hon. Commissioner  
for Patents  
Washington, D.C. 20231

TRANSMITTAL LETTER FOR  
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Transmitted herewith is a Supplemental Information  
Disclosure Statement in the above-identified application.

This Statement is submitted:

- ☒ [X] within three months of the application filing  
date;
- ☐ [ ] more than three months from the application  
filing date but before the mailing date of  
the first Office Action on the merits.

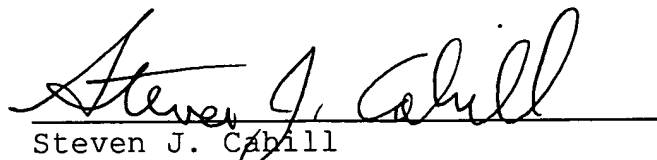
In accordance with 37 C.F.R. § 1.97, submission of  
this Statement requires no fee. However, if for any reason  
a fee is due, the Commissioner is hereby authorized to  
charge payment of any fees required in connection with this  
Information Disclosure Statement to Deposit Account

MSI-1

03/07  
H2/KDS.  
B2/WJW  
1-15-01

No. 06-1075. A duplicate copy of this letter is transmitted herewith.

Respectfully submitted,



Steven J. Cabill  
Registration No. 44,578  
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Correspondence is being  
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Signature of Person Signing

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 For : WAFER SURFACE THAT FACILITATES  
 PARTICLE REMOVAL

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Hon. Assistant Commissioner  
 for Patents  
 Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.56, 1.97, and 1.98, applicants wish to call the attention of the Examiner to the following documents:

U.S. Patent Application

09/560,626 N. Johan Knall 04/28/2000

This document is listed on the accompanying Form PTO-1449 (submitted in duplicate) and a copy is enclosed herewith.

Consideration of the foregoing in relation to this patent application is respectfully requested.

Respectfully submitted,

Thereby Certify that this  
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